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| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO. | |
|--|-----------------|----------------------|-------------------------|--------------------|--|
| 10/711,512 | 09/23/2004 | Chien-Hung Lu | 13622-US-PA | 5511 | |
| 31561 | 7590 06/14/2005 | | EXAMINER | | |
| JIANQ CHYUN INTELLECTUAL PROPERTY OFFICE 7 FLOOR-1, NO. 100 ROOSEVELT ROAD, SECTION 2 TAIPEI, 100 | | | HARRISON, | HARRISON, MONICA D | |
| | | | ART UNIT | PAPER NUMBER | |
| | | | 2813 | | |
| TAIWAN | | | DATE MAILED: 06/14/2005 | | |

Please find below and/or attached an Office communication concerning this application or proceeding.

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| | Application No. | Applicant(s) | | | | |
|---|---|--|--|--|--|--|
| Office Action Summer | 10/711,512 | LU ET AL. | | | | |
| Office Action Summary | Examiner | Art Unit | | | | |
| | Monica D. Harrison | 2813 | | | | |
| The MAILING DATE of this communication app Period for Reply | ears on the cover sheet with the co | orrespondence address | | | | |
| A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period w Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). | 6(a). In no event, however, may a reply be tim within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from to become ABANDONEE | ely filed will be considered timely. he mailing date of this communication.) (35 U.S.C. § 133). | | | | |
| Status | | | | | | |
| 1) Responsive to communication(s) filed on <u>23 September 2004</u> . | | | | | | |
| 2a) ☐ This action is FINAL . 2b) ☒ This | ☐ This action is FINAL. 2b) ☑ This action is non-final. | | | | | |
| ·— ·· | Since this application is in condition for allowance except for formal matters, prosecution as to the merits is | | | | | |
| closed in accordance with the practice under E | x parte Quayle, 1935 C.D. 11, 45 | 3 O.G. 213. | | | | |
| Disposition of Claims | | | | | | |
| 4) Claim(s) 1-15 is/are pending in the application. 4a) Of the above claim(s) is/are withdrawn from consideration. | | | | | | |
| · — · · · — — | Claim(s) <u>1-10</u> is/are allowed. Claim(s) <u>11</u> is/are rejected. Claim(s) 12-15 is/are objected to | | | | | |
| 7)⊠ Claim(s) <u>12-15</u> is/are objected to. | | | | | | |
| , | | | | | | |
| Application Papers | | | | | | |
| 9) The specification is objected to by the Examine | Γ. • | | | | | |
| | The specification is objected to by the Examiner. DIM The drawing(s) filed on <u>23 September 2004</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner. | | | | | |
| • | Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). | | | | | |
| Replacement drawing sheet(s) including the correct | | | | | | |
| Priority under 35 U.S.C. § 119 | • | | | | | |
| 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. | | | | | | |
| • | | | | | | |
| Attachment(s) | | | | | | |
| 1) Notice of References Cited (PTO-892) | 4) 🔲 Interview Summary | | | | | |
| Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date | Paper No(s)/Mail Do 5) Notice of Informal P 6) Other: | ate latent Application (PTO-152) | | | | |

DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claim 11 is rejected under 35 U.S.C. 102(e) as being anticipated by Olgado et al (6,770,565 B2).

1. Regarding claim 11, Olgado et al discloses a method for improving uniformity of thickness of a thin film, adapted for a chemical vapor deposition process, comprising: forming the thin film with uniform thickness (Figure 8, reference 804) by rotating a wafer with an angle (Figure 8, reference 806) while depositing the thin film on the wafer (column 10, lines 40-67 thru column 11, lines 1-16.

Allowable Subject Matter

- 2. Claims 12-15 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
 - 3. Claims 1-10 are allowed over the prior art of record.

Reasons for Allowance

4. The following is an examiner's statement of reasons for allowance: The primary reason for allowance of the claims is that the prior art neither teaches nor fairly suggest a high

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density plasma chemical vapor deposition process comprising a deposition system that is adapted to deposit the thin film comprises n gas output holes, wherein the first and the second deposition steps require a time interval, and at one half of the time interval, the wafer is rotated at the angle of 360/2n degrees, and n is an integer in claims 1-4 and in the context of the recited process.

The primary reason for allowance of the claims is that the prior art neither teaches nor fairly suggest a high density plasma chemical vapor deposition process comprising a deposition system that is adapted to deposit the thin film comprises n gas output holes, and performing the first and the second deposition steps require a time interval, wherein at 1/m of the time interval, the wafer is rotated at the angle of 360/(m*n) degrees, and m and n are integers in claims 5-10 and in the context of the recited process.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Monica D. Harrison whose telephone number is 571-272-1959. The examiner can normally be reached on M-F 7:00am-3:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Monica D. Harrison AU 2813

mdh June 9, 2005

> CRAIG A. THOMPSON PRIMARY EXAMINER

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